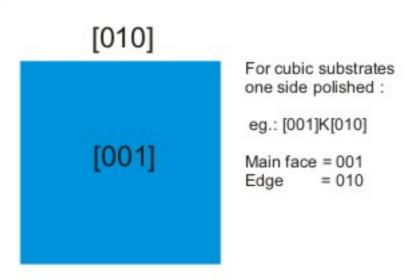
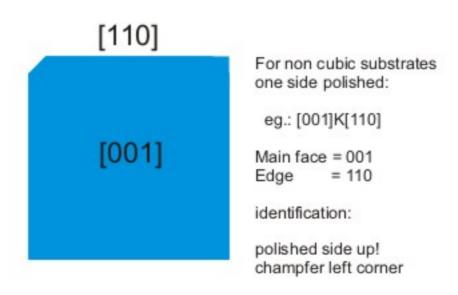
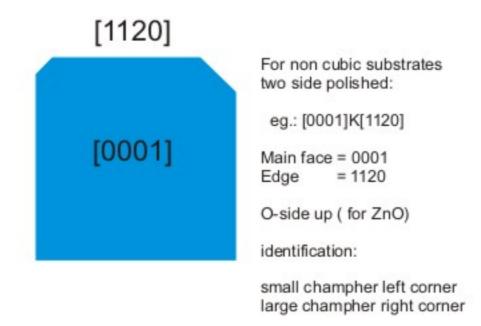
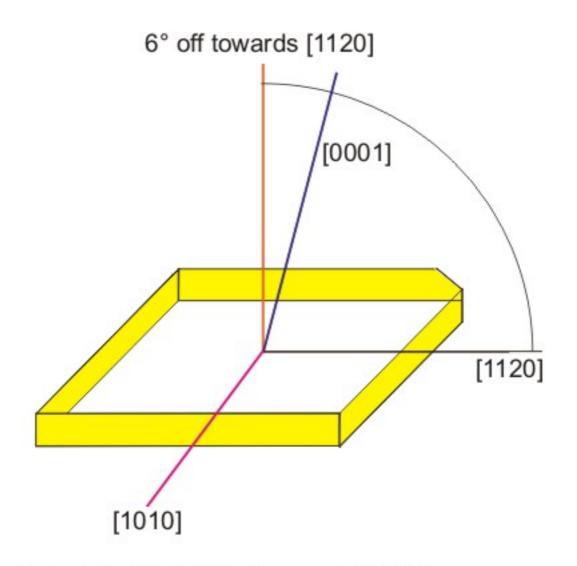
Definition for ordering one or two sides polished substrates







Definition for ordering "off cut" substrates



Order info: [0001]6° off towards [1120]

<u>Definition for ordering substrates</u>, (nomenclature)

eg.: ZnO
[0001] orientation of polished face
[1120] orientation of edge
Zn side polished face
10 mm size A
10 mm size B
0,5 mm thick
CMP polishing quality

ZnO [0001]K[1120]Zn epi pol 10x10x0,5 CMP

Polishing qualities:

CMP chemo mechanical polishing (best possible polishing nominal ra better then the lattice constant) fpr epitaxial applications.

OPT optical polishing (good quality optical polishing for non epitaxial applications)

10/20 scratch/dig ration polishing quality (mostly used for optical component regarding DIN or ASTM numbers)

General qualities/grades:

epi or cmp pol. = top grade polished materials
r&d grade = test grade, small defects must be expectet